

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
University of California San Diego	12/01/2010
RECEIVING PARTY DATA	
Name:	National Science Foundation
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Invention Title: Direct epitaxial growth of III/V semiconductor nanowires on Si

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Foreign Applications filed/intended in (countries): _____

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this 1st day of December 2010.
 By William Decker (Institutional Business Official) [Signature] (Signature)

Title Associate Director, Technology Transfer

For UNIVERSITY OF CALIFORNIA SAN DIEGO
 (Grantee/Contractor Organization)

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